

PATENT NUMBER AND
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10076858	02/14/2002	428	428	1775	Stein

**APPLICANTS: Steinberg Dan; Rasnake Jasean; Sherrer David;

**CONTINUING DATA VERIFIED:

THIS APPLN CLAIMS BENEFIT OF 60/269,011 02/14/2001
AND CLAIMS BENEFIT OF 60/269,010 02/14/2001

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed 35 USC 119 conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO 23091/25
Verified and Acknowledged Examiners's initials		
TITLE : Micromachined structures made by combined wet and dry etching		
U.S. DEPT. OF COMM./PAT. & TM-PTO-436L(Rev. 12-94)		

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claims for 0/0
ISSUE FEE		DRAWING FIGURES	
Amount Due	Date Paid	Sheets Drawg.	Fig. Drawg.
TERMINAL		Print Fig.	
DISCLAIMER		Application Examiner	
Primary Examiner			
PREPARED FOR ISSUE			
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